

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:

Jeff Mackey

Serial No.: 10/415.955

Filed: November 15, 2003

For: POLARIZED RETICLE, PHOTOLITHOGRAPHY SYSTEM, AND METHOD OF FORMING A PATTERN USING A POLARIZED RETICLE IN CONJUNCTION WITH POLARIZED

LIGHT

Confirmation No.: Unknown

Examiner: Unknown

Group Art Unit: Unknown

Attorney Docket No.: 2269-6102US

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

March 1, 2004

Date

Deidra J. Pfeil

Name (Type/Print)

PRELIMINARY AMENDMENT

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

Prior to examination of the above-referenced patent application on the merits, entry of the amendments as set forth herein is respectfully solicited.

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing which begins on page 9 of the paper.

Amendments to the Drawings appear on page 19 of this paper and include both an annotated sheet showing changes and replacement formal drawings.

Remarks begin on page 20 of this paper.

An Appendix including amended drawing figure is attached following page 20 of this paper.